

<b>Search Notes</b> 	<b>Application/Control No.</b> 09/270,780	<b>Applicant(s)/Patent under Reexamination</b> HIYAMA ET AL.
	<b>Examiner</b> Mike Qi	<b>Art Unit</b> 2871

**SEARCHED**

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
349	96 (PGPUB3)	9/12/05	220
61	65		